## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Gregory E. Howard, et al.

Docket No: TI-29600.1

Serial No:

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**TBD** 

Art Unit:

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11/21/2003

For:

METHOD FOR CONSTRUCTING A METAL OXIDE SEMICONDUCTOR FIELD EFFECT

**TRANSISTOR** 

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

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Ann Trent

## PRELIMINARY AMENDMENT

Dear Sir:

Prior to the examination of the above identified application, Applicants respectfully submit the following amendments and remarks.